

CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)Applicant(s): **TANABE et al.**

Docket No.

NEC WNZ-2212

Serial No.

09/612,551

Filing Date

July 7, 2000

Examiner

Geoffrey S. Evans

Group Art Unit

1725Invention: **SEMICONDUCTOR THIN FILM FORMING SYSTEM**

I hereby certify that this Amendment F under Rule 116 and Petition for One Month Extension of Time
(Identify type of correspondence)


is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. 703-872-9311)

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Transmitted herewith:

1. Amendment F under Rule 116 (3 pgs);
2. Petition for One Month Extension of Time (1 pg); and
3. form PTO-2038 for Extension fees (1 pg).